

Serial No.:

Filed:

Entitled:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Recessed Shallow Trench Isolation Structure Nitride

Liner and Method of Making Same

Group Art Unit: 2811

Group Air Onic. 201

Examiner: T. TRAN

Docket No.:

97 P 9371 US 027

Ê

Batch No.:

TBD

LETTER TO OFFICIAL DRAFTSMAN

Attention: Drawing Processing Branch Assistant Commissioner for Patents Washington, D.C. 20231

Rengarajan et al.

December 30, 1997

09/000,626

Sir:

Pursuant to M.P.E.P. Section 608.02, enclosed please find six (6) sheets of formal drawings in the referenced case. These are formal versions of the informal drawings filed with the application.

If there are any informalities with these drawings, Applicant requests issuance of a Form PTO-948 identifying the informalities noted by the Official Draftsman.

Date: December 3, 2001

Infineon Technologies North America Corp. c/o Siemens Corporation
Intellectual Property Department
186 Wood Avenue South
Iselin, NJ 08830
(732) 321-3015
SCB/vl

Respectfully submitted,

Stanton C. Braden

Reg. No. 32,556

CERTIFICATE OF MAILING PURSUANT TO 37 CFR § 1.8

I hereby certify that this correspondence is being deposited on or before the date, <u>December 3, 2001</u> with the United States Postal Service with sufficient postage as first class mail in an envelope addressed Assistant Commissioner for Patents, Washington, D.C. 20231

Date of Signature: December 3, 2001

Pamela I Gewintz